

Edit Saved Searches for User *ogabor*

Queries 387 through 436.

<input type="text"/>	Find		
<input type="button" value="New"/>	<input type="button" value="Edit"/>	Next	Oldest
<input type="button" value="Update"/>	<input type="button" value="Quit"/>	<input type="button" value="Help"/>	
<input type="button" value="Delete"/>	<input type="button" value="Delete ALL"/>		

S #	Comment	Database	Query String	Delete?
S436		TDBD	(crystal adj quality) and (intensity adj ratio)	<input type="checkbox"/>
S435		DWPI	(crystal adj quality) and (intensity adj ratio)	<input type="checkbox"/>
S434		JPAB	(crystal adj quality) and (intensity adj ratio)	<input type="checkbox"/>
S433		EPAB	(crystal adj quality) and (intensity adj ratio)	<input type="checkbox"/>
S432		PGPB	(crystal adj quality) and (intensity adj ratio)	<input type="checkbox"/>
S431		USPT	(crystal adj quality) and (intensity adj ratio)	<input type="checkbox"/>
S430		USPT	(polysilicon) and (intensity) and reflect\$ and (first adj (detector or sensor)) and (second adj (detector or sensor)) and (beam adj splitter) and (splitting adj ratio)	<input type="checkbox"/>
S429		PGPB	(polysilicon) and (intensity) and reflect\$ and (first adj (detector or sensor)) and (second adj (detector or sensor)) and (beam adj splitter) and (splitting adj ratio)	<input type="checkbox"/>
S428		USPT	(polysilicon) and (intensity) and reflect\$ and (first adj (detector or sensor)) and (second adj (detector or sensor)) and (beam adj splitter) and (splitting adj ratio)	<input type="checkbox"/>
S427		USPT	(polysilicon) and (intensity and ratio) and reflect\$ and (first adj (detector or sensor)) and (second adj (detector or sensor)) and (beam adj splitter)	<input type="checkbox"/>
			(polysilicon) and (intensity adj ratio) and reflect\$ and (first adj (detector or sensor)) and	

S426		USPT	(second adj (detector or sensor)) and (beam adj splitter)	<input type="checkbox"/>
S425		PGPB	(polysilicon) and (intensity adj ratio) and reflect\$ and (first adj (detector or sensor)) and (second adj (detector or sensor)) and (beam adj splitter)	<input type="checkbox"/>
S424		PGPB	(polysilicon) and (intensity) and reflect\$ and (first adj (detector or sensor)) and (second adj (detector or sensor)) and (beam adj splitter)	<input type="checkbox"/>
S423		USPT	(polysilicon) and (intensity) and reflect\$ and (first adj (detector or sensor)) and (second adj (detector or sensor)) and (beam adj splitter)	<input type="checkbox"/>
S422		USPT	(polysilicon) and (intensity) and reflect\$ and (first adj (detector or sensor)) and (second adj (detector or sensor))	<input type="checkbox"/>
S421		TDBD	inspect\$ and (polysilicon adj (layer or surface or substrate)) and quality and reflect\$ and (intensity adj ratio)	<input type="checkbox"/>
S420		DWPI	inspect\$ and (polysilicon adj (layer or surface or substrate)) and quality and reflect\$ and (intensity adj ratio)	<input type="checkbox"/>
S419		EPAB	inspect\$ and (polysilicon adj (layer or surface or substrate)) and quality and reflect\$ and (intensity adj ratio)	<input type="checkbox"/>
S418		JPAB	inspect\$ and (polysilicon adj (layer or surface or substrate)) and quality and reflect\$ and (intensity adj ratio)	<input type="checkbox"/>
S417		PGPB	inspect\$ and (polysilicon adj (layer or surface or substrate)) and quality and reflect\$ and (intensity adj ratio)	<input type="checkbox"/>
S416		PGPB	inspect\$ and (polysilicon adj (layer or surface or substrate)) and quality and reflect\$ and intensity and ratio	<input type="checkbox"/>
S415		USPT	inspect\$ and (polysilicon adj (layer or surface or substrate)) and quality and reflect\$ and intensity and ratio	<input type="checkbox"/>
S414		USPT	inspect\$ and (polysilicon adj (layer or surface or substrate)) and quality and reflect\$ and intensity	<input type="checkbox"/>
S413		USPT	inspect\$ and (polysilicon adj (layer or surface or substrate)) and quality and reflect\$	<input type="checkbox"/>

S412		USPT	inspect\$ and (polysilicon adj (layer or surface or substrate)) and quality	<input type="checkbox"/>
S411		USPT	inspect\$ and (polysilicon adj (layer or surface or substrate))	<input type="checkbox"/>
S410		USPT	inspect\$ and (polysilicon adj (layer or surface or substrate))	<input type="checkbox"/>
S409		USPT	inspect\$ and quality and (polysilicon adj (layer or surface or substrate))	<input type="checkbox"/>
S408		TDBD	(polysilicon) and substrate and (beam adj splitter) and (intensity adj ratio) and reflect\$	<input type="checkbox"/>
S407		DWPI	(polysilicon) and substrate and (beam adj splitter) and (intensity adj ratio) and reflect\$	<input type="checkbox"/>
S406		JPAB	(polysilicon) and substrate and (beam adj splitter) and (intensity adj ratio) and reflect\$	<input type="checkbox"/>
S405		EPAB	(polysilicon) and substrate and (beam adj splitter) and (intensity adj ratio) and reflect\$	<input type="checkbox"/>
S404		PGPB	(polysilicon) and substrate and (beam adj splitter) and (intensity adj ratio) and reflect\$	<input type="checkbox"/>
S403		USPT	(polysilicon) and substrate and (beam adj splitter) and (intensity adj ratio) and reflect\$	<input type="checkbox"/>
S402		USPT	250/.ccls. and (polysilicon) and substrate and (beam adj splitter) and (intensity adj ratio) and reflect\$	<input type="checkbox"/>
S401		USPT	250/.ccls. and (polysilicon) and substrate and (first adj light) and (second adj light) and (beam adj splitter) and (intensity adj ratio)	<input type="checkbox"/>
S400		USPT	(direct adj conver\$) and (indirect adj conver\$) and image and charge	<input type="checkbox"/>
S399		USPT	(direct adj conver\$) and (indirect adj conver\$) and image and charge	<input type="checkbox"/>
S398		USPT	(direct adj conver\$) and (indirect adj conver\$)	<input type="checkbox"/>
S397		USPT	(direct adj convert\$) and (indirect adj convert\$)	<input type="checkbox"/>
S396		USPT	6185274.pn. and (convert\$)	<input type="checkbox"/>
S395		USPT	6185275.pn. and (convert\$)	<input type="checkbox"/>
S394		USPT	6674470.pn. and (convert\$)	<input type="checkbox"/>
S393		USPT	6674470.pn. and (conversion) and scintillat\$	<input type="checkbox"/>